



Serial No. 10/717,934
OKI.597
Amendment dated January 3, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Makoto Terui et al. Group Art Unit: 2823

Serial No.: 10/717,934 Examiner: W. Brewster

Filed: November 21, 2003 Confirm No.: 7542

For: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE HAVING A
HEAT RADIATION LAYER

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, Mail Stop RCE
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: January 3, 2006
(Tuesday after Federal Holiday)

Sir:

In response to the Final Office Action dated September 2, 2005, the period for response having been extended one (1) month to January 2, 2006, the following amendments and remarks are respectfully submitted, concurrently along with a Request for Continued Examination (RCE), in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

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Remarks/Arguments begin on page 10 of this paper.